

2812



In re Application of:

MASATAKA ITO

Application No.: 10/091,461

Filed: March 7, 2002

RECEIVED

SEP 17 2002

TECHNOLOGY CENTER 2800

Docket No. 00862.022541.

Examiner: S. Isaac

Group Art Unit: 2812

Date: September 12, 2002

For: SOI SUBSTRATE, ANNEALING METHOD THEREFOR, SEMICONDUCTOR DEVICE HAVING THE SOI SUBSTRATE, AND METHOD OF MANUFACTURING THE SAME

COMMISSIONER FOR PATENTS
Washington, D.C. 20231

Sir:

Transmitted herewith is an amendment in the above-identified application.

☒ No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED						
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	* 16	MINUS	** 20	= 0	x \$9 \$18	-0-
INDEP. CLAIMS	* 2	MINUS	*** 3	= 0	x \$42 \$84	-0-
Fee for Multiple Dependent claims \$140°/\$280						
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT---						-0-

- * If the entry in Column 2 is less than the entry in Column 4, write "0" in Column 5.
- ** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.
- *** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space.

☐ °Verified Statement claiming small entity status is enclosed, if not filed previously.

☐ A check in the amount of \$_____ is enclosed.

☐ Charge \$_____ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.

☒ Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.

☐ A check in the amount of \$____ to cover the fee for a ____ month extension is enclosed.

☐ A check in the amount of \$____ to cover the Information Disclosure Statement fee is enclosed.

☒ Applicant's undersigned attorney may be reached in our Costa Mesa, California office by telephone at (714) 540-8700. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicant

Registration No. 39,000

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

CA_MAIN 49736 v 1

A circular black ink stamp from the Office of Intellectual Property (OIP). The text "OIP" is at the top, "PATENT & TRADEMARK OFFICE" is at the bottom, and "SEP 13 2002" is in the center. There is also a small "JC139" at the top right and "00" at the far right.

PATENT APPLICATION RECEIVED

SEP 17 2002

TECHNOLOGY CENTER 2800
OFFICE

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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AND METHOD OF
MANUFACTURING THE SAME

September 12, 2002

Commissioner for Patents
Washington, D.C. 20231

AMENDMENT

Sir:

In response to the Office Action dated June 13, 2002, please amend the above-identified application as follows: